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Atty. Dkt. No. 039153-0529 (G1234)

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Applicant: Ercan Adem

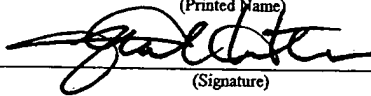
Title: METHOD OF ULTRA-LOW
ENERGY ION IMPLANTATION
TO FORM ALLOY LAYERS IN
COPPER

Appl. No.: 10/803,852

Filing Date: March 18, 2004

Examiner: Gurley, Lynne Ann

Art Unit: 2812

<p>CERTIFICATE OF MAILING</p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.</p> <p><u>Paul S. Hunter</u> (Printed Name)</p> <p><u></u> (Signature)</p> <p><u>December 8, 2005</u> (Date of Deposit)</p>
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AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Ms. Gurley:

This communication is responsive to the Final Office Action dated 12/01/2005, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: